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APPLICANTS

Sung-Kwon Lee, Ichon-shi, KOREA, REPUBLIC OF;

\*\* CONTINUING DATA \*\*\*\*\* *none* *K-CC*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *K-CC*

REPUBLIC OF KOREA 2002-85131 12/27/2002  
 REPUBLIC OF KOREA 2002-86489 12/30/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>K-CC</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 12	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 3
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TITLE  
 Method for fabricating semiconductor device using ArF photolithography capable of protecting tapered profile of hard mask

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of
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